

10-16-03

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PATENT
Atty. DKL AMAT/3421.C1/CMP/ECP/RKK



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Cheung, et al.

Serial No.: 09/609,347

Confirmation No.: 5540

Filed: July 5, 2000

For: APPARATUS FOR ELECTRO
CHEMICAL DEPOSITION OF COPPER
METALLIZATION WITH THE
CAPABILITY OF IN-SITU THERMAL
ANNEALING

Group Art Unit: 1753

Examiner: Brian Mutschler

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TC 1700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10	
I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 10/15/2003 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV349862143US addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Date 10/15/03	Signature

PETITION FOR THREE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a three-month extension of time to and including October 16, 2003, in which to file a Continuation Application.

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$950.00 and any additional fees which may be required for this submission to Deposit Account No. 50-1074/3421.C1/CMP/ECP/RKK.

Respectfully submitted,

ROBERT W. MULCAHY
Registration No. 25,436
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd. Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicant(s)

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